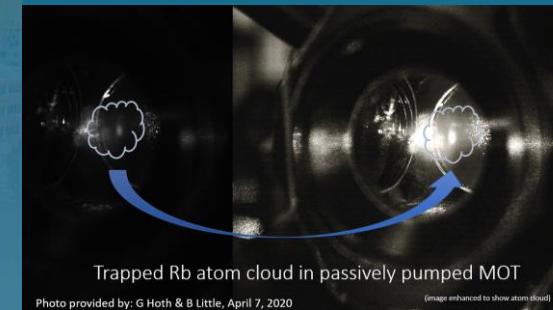




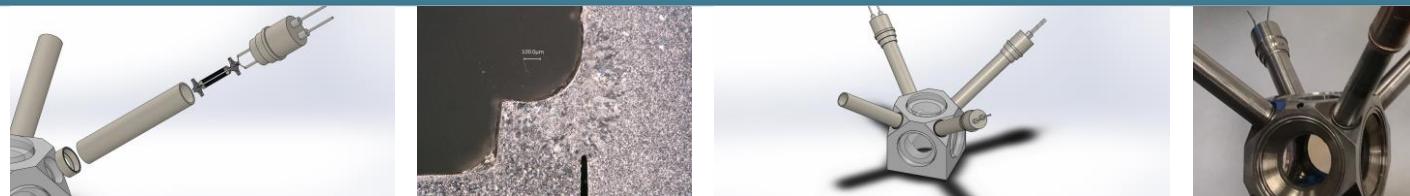
Sandia  
National  
Laboratories

# Fabricating a passively pumped vacuum chamber for cold-atom experiments



Trapped Rb atom cloud in passively pumped MOT

Photo provided by: G Hoth & B Little, April 7, 2020



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## 2021 International Brazing and Soldering Conference

October 3-6, 2021

Denver, Colorado



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## Vision/Motivation

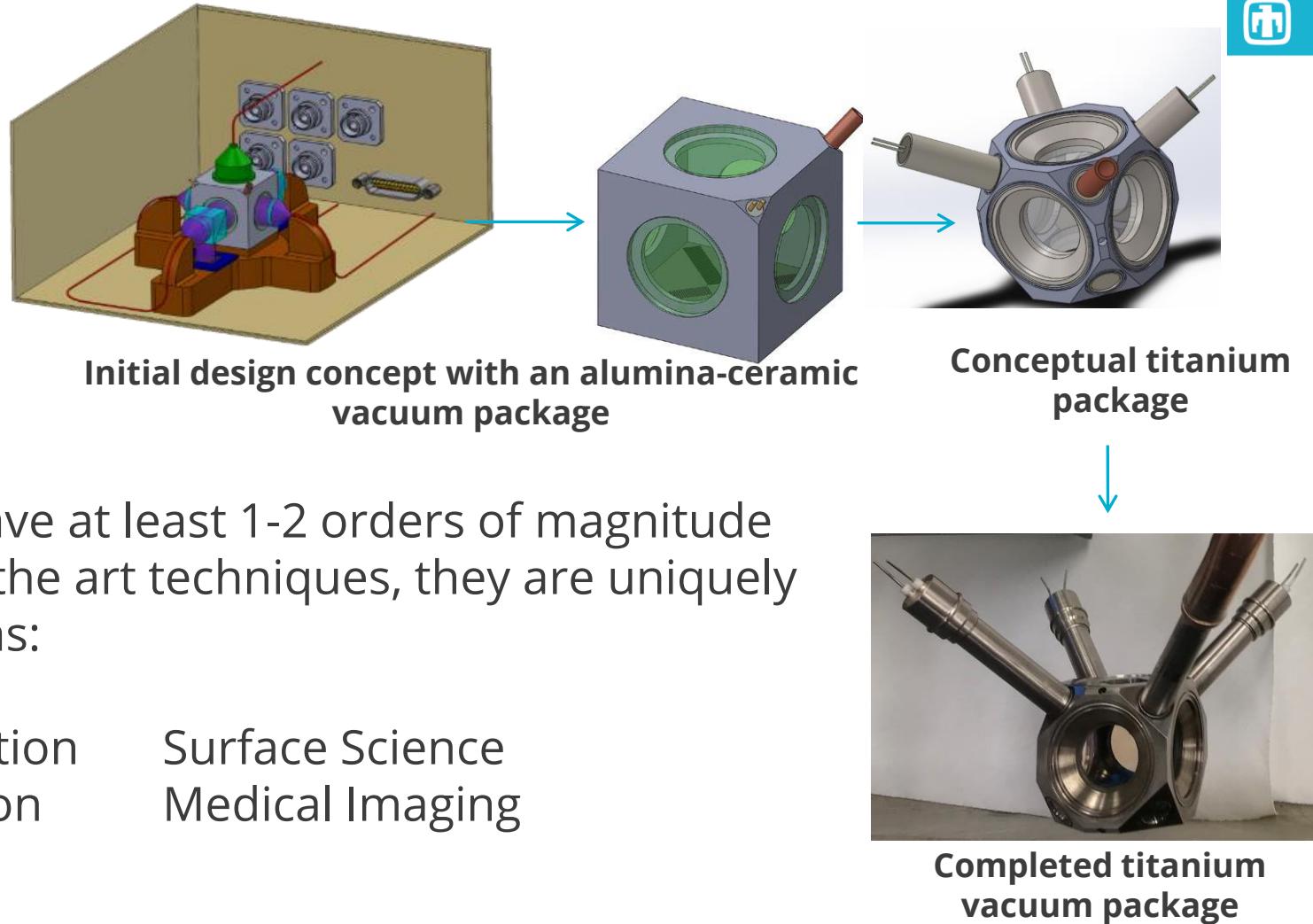
“Build the world’s first truly portable, compact atom interferometer inertial sensor.”

Because quantum sensors generally have at least 1-2 orders of magnitude better resolution than current state of the art techniques, they are uniquely suited to be used in such applications as:

Timing  
Navigation  
Gravimetry

Non Destructive Evaluation  
Trace Chemical Detection

Surface Science  
Medical Imaging



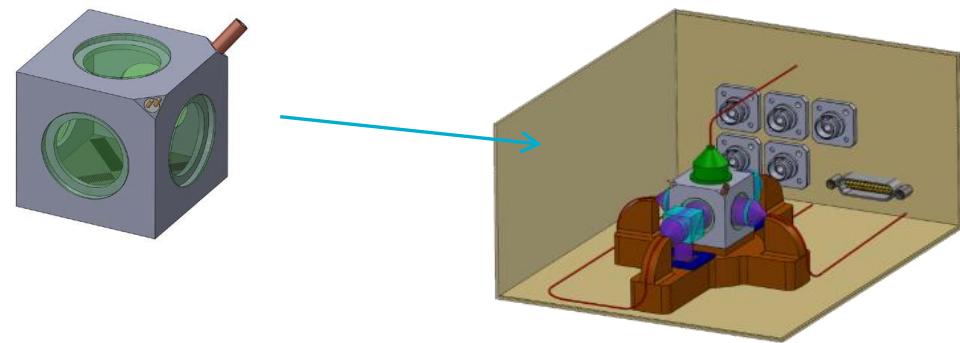
This presentation, approximately 15 minutes in duration, will summarize a 3-year multi-person effort, describing how small vacuum chambers, capable of supporting a magneto optical trap (MOT), via laser-cooling\*, were successfully fabricated.

\*Temperature:  $\sim 5\mu\text{K}$  ( $5 \times 10^{-6}$  Kelvin)

# Background: High-vacuum Chamber Features

## Required features

- Supply alkali metal (Rb) atoms
- Non or nearly nonmagnetic chamber and feedthroughs
- Small footprint,  $\sim 5 \text{ cm}^3$  volume to function as an atom interferometer (AI) accelerometer
- Must provide optical windows for laser access
- Must have negligible helium permeation
- **\*Maintain high-vacuum for months**
  - $P_{\text{Rb}} \sim 10^{-7} \text{ Torr}$ ;  $P_{\text{background}} \sim 10^{-8} \text{ Torr}$



## Desired Features

- **\*Electrically activated contaminant-free alkali metal source.**
- 100% glass-free
- Windows with nearly zero helium permeability, AR coating, and no birefringence
- Include passive (getter) pumping
- Support up to 6 months “pumpless” vacuum package operation.
- MOT diffraction grating internal to vacuum package
- Copper pinch-off tube for sealing
- Bakeable to  $\sim 400^\circ \text{C}$ .
- Zero/low electrical conductivity (<<< eddy currents)

## \*Key Vacuum System Challenges

# Materials & Components Selection



Component	Material	Heat sensitive	Atmosphere sensitive	Notes
<b>Chamber</b>	Titanium*	No	No	Grade-2 (commercially pure). Can be welded without the formation of intermetallics
<b>Chamber</b>	Alumina Ceramic	No	No	94% - 98% $\text{Al}_2\text{O}_3$
<b>Non-evaporable getters (NEG)</b>	NEG, St 172*	Yes	Yes	Sensitive above 250°C in $\text{O}_2$ containing environments
<b>Alkali Metal Dispenser (AMD)</b>	AMD, Rb*	Yes	Yes	Sensitive above 250°C in $\text{O}_2$ containing environments
<b>Window</b>	<b>Sapphire w/Ti frame*</b>	No	No	Brazed into frames. Able to withstand 450°C+ temperatures
<b>Window</b>	Sapphire w/o frame	Yes	No	CTE mismatch with Ti body could be problematic
<b>Window</b>	Fused Silica w/Ti frame	No	No	Brazed into frames. Able to withstand 450°C+ temperatures
<b>Window</b>	Fused Silica w/o frame	Yes	No	CTE mismatch with Ti body could be problematic
<b>Grating MOT</b>	Si wafer*	Yes	No	Need to keep below 250°C
<b>Electrical feedthroughs</b>	<b>Ti bodies, Mo* conductors</b>	No	No	Grade-2 Ti, brazed to $\text{Al}_2\text{O}_3$ insulators and Mo pins
<b>Electrical feedthroughs</b>	Stainless-steel bodies	No	No	Used initially until Ti bodies became available. Pins are Mo.
<b>NEG &amp; AMD bodies</b>	<b>Ti tubing*</b>	No	No	Grade-2 Ti
<b>Exhaust tubing</b>	<b>Ti and/or Ti/Cu*</b>	No	No	Brazed to adapters as needed.

\*Candidate materials selected for first iteration of vacuum chamber assemblies

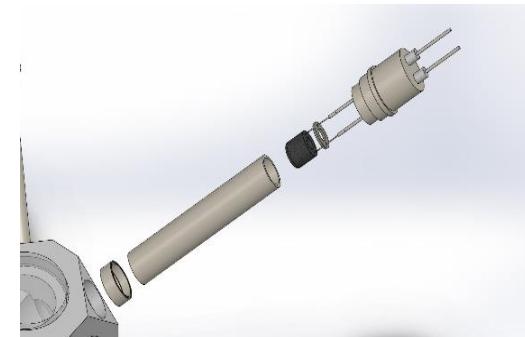
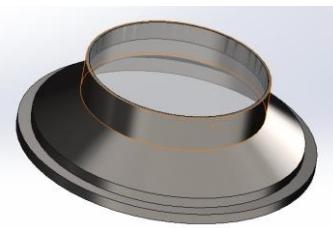
# Chamber Components Construction



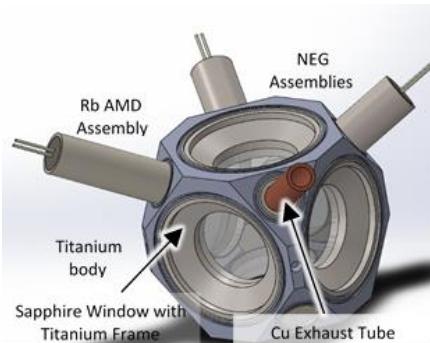
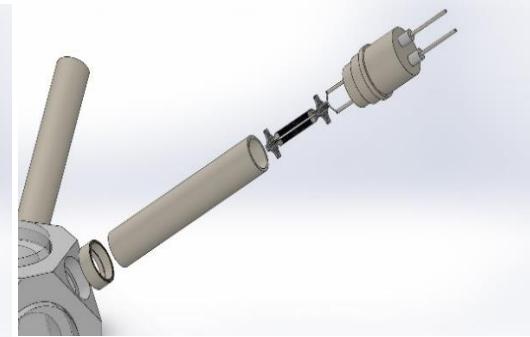
**Window Assemblies  
Getter Assemblies  
Alkali Metal  
Dispensers  
Exhaust Manifolds**



Sapphire window/CP titanium flanges



Non-evaporable getter assembly (L), Alkali metal dispenser assembly (R)



Sapphire window/CP titanium flanges

## Joining Processes

### Welding Processes

- Pulsed-laser
- Resistance
- Orbital
- TIG

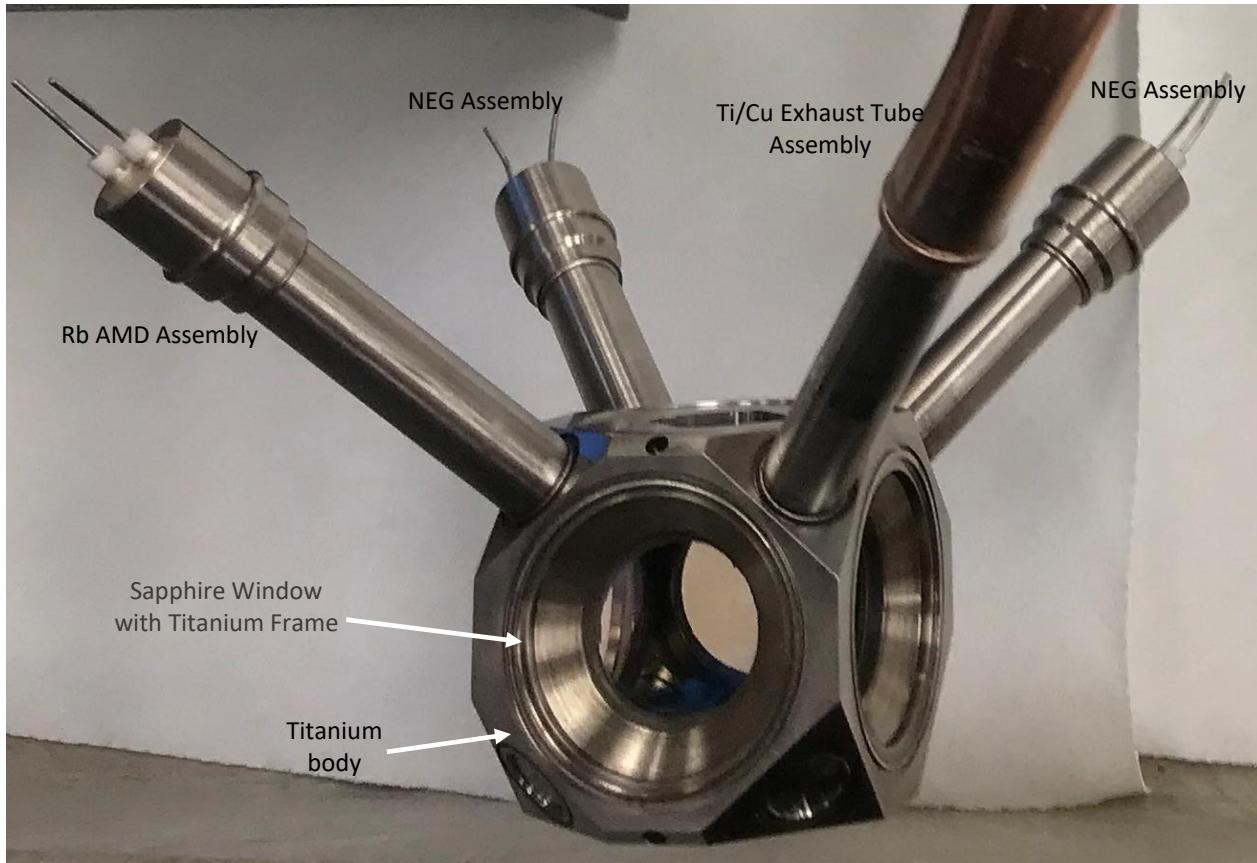
### Brazing Processes

- Vacuum Furnace
- Hydrogen/Oxygen Torch
- Hand-held Induction



Pulsed-laser welding of CP titanium

# Titanium Vacuum Chamber Fabrication



Completed Titanium Vacuum Package



Solid-model of Titanium chamber/UHV manifold assembly

# Sapphire-Alumina Ceramic Braze Development



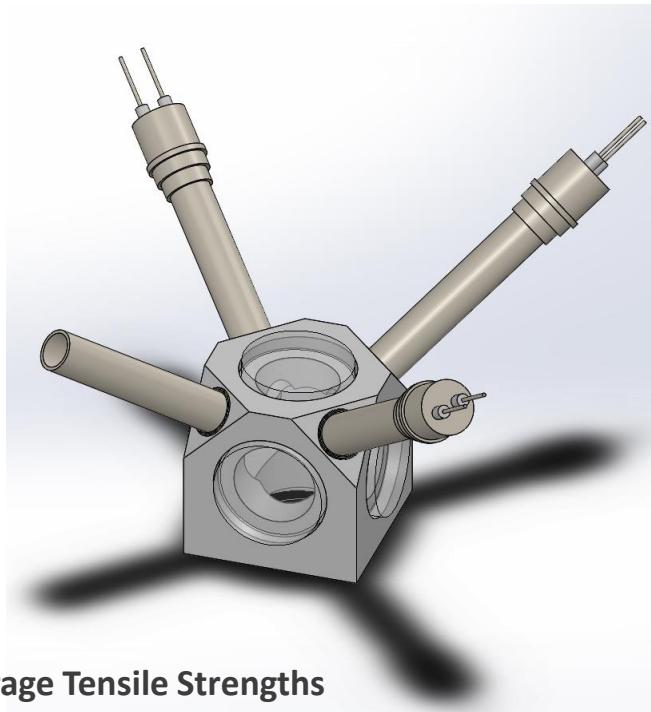
## Alumina-ceramic chamber design restrictions:

- Ten simultaneous active filler metal brazements (6 ea. sapphire window, 4 titanium weld sleeves) was determined to be too risky, as any leaks detected would be difficult to repair.
- The requirement that any metallization system used be nonmagnetic eliminated those utilizing nickel plating.

## Solution:

A COTS titanium-hydride/organic carrier metallization system (Tiger Ink) was selected for use after robust testing using with conventional silver-based brazing filler metals (BVAg-0, BVAg-8, and BVAg-29).

All of the ceramic tensile button samples and sapphire window-ceramic window frame samples fabricated using the Tiger-Ink metallization were hermetic (Helium leak rate <5E-12 atm/cc-sec).

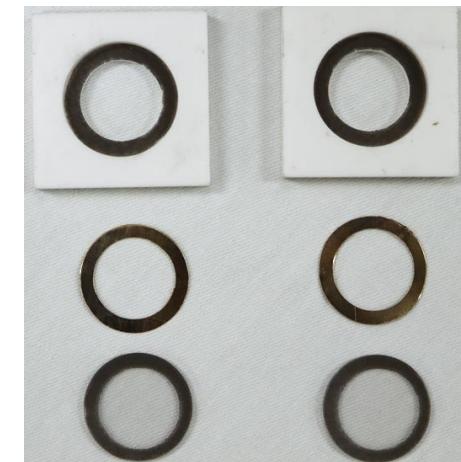


## Average Tensile Strengths

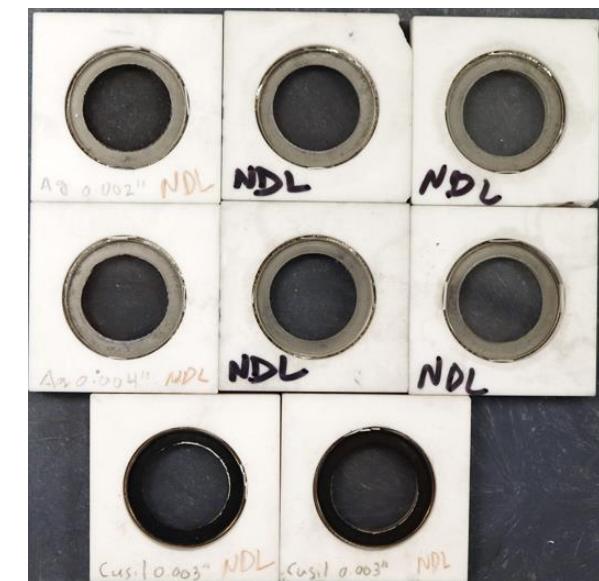
96% Alumina Ceramic ASTM F-19  
Tensile Buttons w/TiH<sub>2</sub> metallization.  
No metal interlayers.

Braze Filler Metal AWS Classification	Stress at failure KSI / MPa
BVAg-0	21.4 / 147.5
BVAg-8	23.7 / 163.4
BVAg-29	22.8 / 157.2

Tensile testing (ASTM F-19)  
Instron 5969, Rate:  $3 \times 10^{-4}$  inch/sec

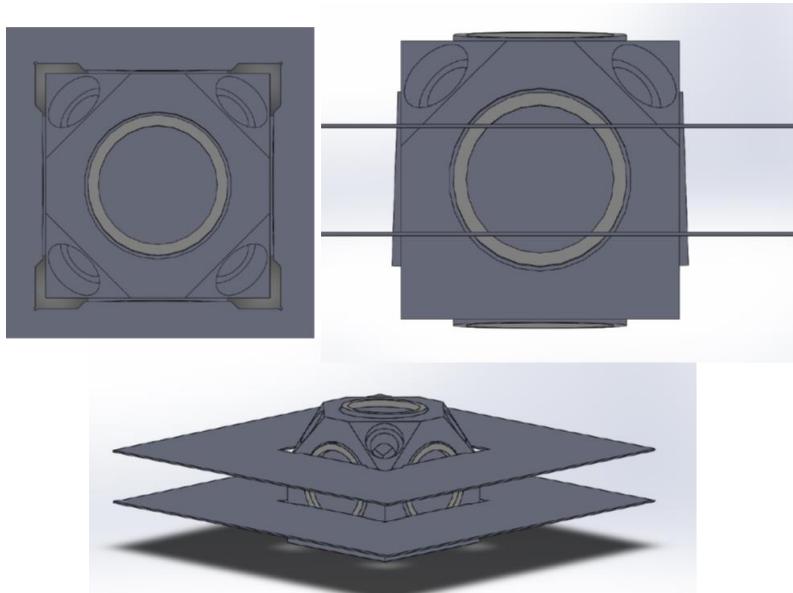


Metallized ceramic and sapphire windows with BFM preforms

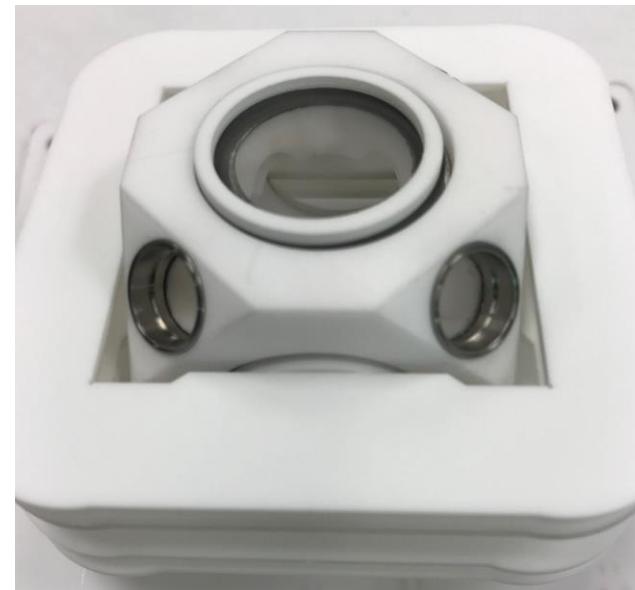


Brazed Alumina ceramic-sapphire window samples.

# Alumina-Ceramic Vacuum Chamber Assembly



Solid Model of Ceramic Chamber with  
Laser-Machined Alumina Ceramic  
Fixturing



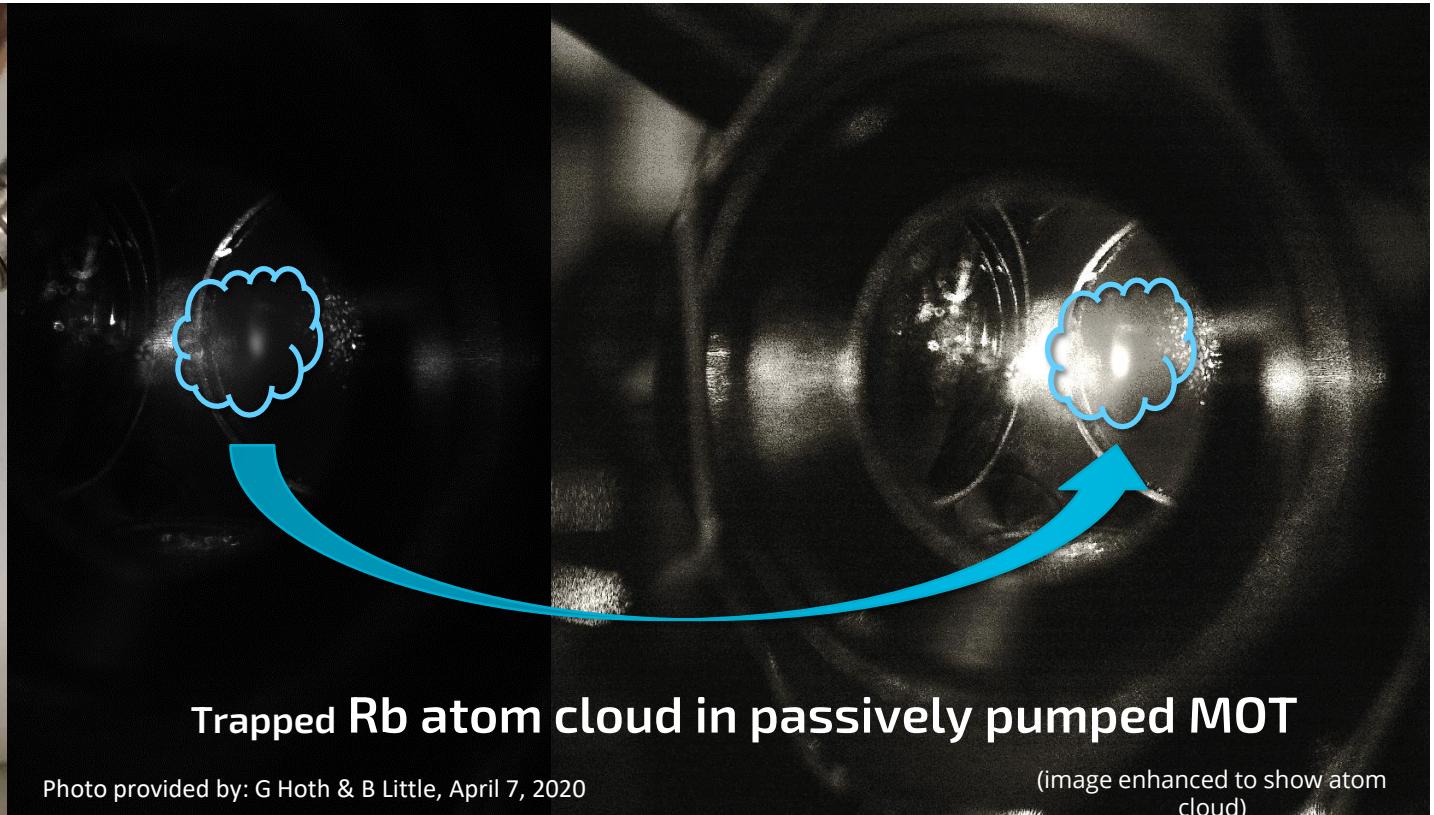
Alumina Ceramic Chamber with Laser-  
Machined Alumina Ceramic Fixturing Prior  
to Brazing



Brazed Ceramic  
Chamber

# Conclusion

- Multiple small titanium vacuum chambers, capable of supporting a magneto optical trap (MOT), via laser-cooling were successfully fabricated and tested.
- Alumina ceramic chambers were partially constructed, but not completed.
- Chambers removed from external vacuum sources have been supporting a MOT for over 450 days.



# Thank you for your time & attention!



Technical assistance and expertise from the following people helped make this program a tremendous success:

Justin Christensen, Peter Duran, Jack Herrmann, , Greg Hoth, Toby Johnson, Peter Kinney, Jongmin Lee, Bethany Little, Christina Profazi, Mark Reece, Jeff Rodelas, Peter Schwindt, James Scott, Dan Tung, Matt Vieira